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	FORM		First N	lamed Inventor	Xie, Jun		
š T	to be used for all correspondence after in	itial filing)	Art Un	it	Not Yet Assigned		
			Exami	ner Name	Not Yet Assigned		
	Total Number of Pages in This Submission	6	Attorn	ey Docket Number	020859-002510US		
ĺ		ENC	LOSURE	S (Check all that apply	<u> </u>		
	Fee Transmittal Form		Drawing(s)		After Allowance Communication to Group		
	Fee Attached	Licensi	ng-relate	d Papers	Appeal Communication to Board of Appeals and Interferences		
	Amendment/Reply	Petition	1		Appeal Communication to Group (Appeal Notice, Brief, Reply Brief)		
	After Final		i to Conv onal App		Proprietary Information		
	Affidavits/declaration(s)			ey, Revocation espondence Address	Status Letter		
	Extension of Time Request	Termin	al Discla	imer	Other Enclosure(s) (please identify below):		
	Express Abandonment Request	Request for Refund CD, Number of CD(s)			Return Postcard; and		
	Information Disclosure Statement (2 pgs) w/attached PTO/SB/08A (1 pg), and PTO/SB/08B (1 pg) (citing refs 1-27)			(-),	2. A copy of each of 27 references.		
	Certified Copy of Priority Document(s)	Rema	The Commissioner is authorized to charge any additional fees to D Account 20-1430.				
	Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53	* Note: R	eferenc	es not included in t	he total number of pages above.		
Ì	SIGN	ATURE O	F APPL	ICANT, ATTORNEY,	OR AGENT		
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	Individual Kent J. Tobin			Reg. No	o. 39,496		
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	Date 4/21/04						
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4-23-04

APR 2 6 2004

TOWNSEND and TOWNSEND and CREW LLP

By: Edward Masmas

Edward Masinas

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Jun Xie et al.

Application No.: 10/757,973

Filed: January 13, 2004

For: INTEGRATED ELECTROSTATIC PERISTALTIC PUMP METHOD AND

APPARATUS

Examiner: Not Yet Assigned

Art Unit: Not Yet Assigned

INFORMATION DISCLOSURE

STATEMENT UNDER 37 CFR §1.97 and

§1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Jun Xie et al.

Application No.: 10/757,973

Page 2

Applicant believes that <u>no fee is required</u> for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,

Kent J. Tobin Reg. No. 39,496

TOWNSEND and TOWNSEND and CREW LLP Two Embarcadero Center, Eighth Floor San Francisco, California 94111-3834

Tel: 650-326-2400 Fax: 650-326-2422

KJT:rms 60186224 v1



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 2

	Complete if Known
Application Number	10/757,973
Filing Date	January 13, 2004
First Named Inventor	Xie, Jun
Art Unit	Unassigned
Examiner Name	Unassigned
Attorney Docket Number	020859-002510US

			U.S. PATENT DO	DCUMENTS+	
		Document Number			
Examiner Initials*	Cite No. ¹	Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	1	US 5,836,750	11-17-1998	Cabuz	- I Service Production
	2	US 6,033,191	03-07-2000	Kamper et al.	
_	3	US 6,062,256	05-16-2000	Miller et al.	
	4	US 6,109,889	08-29-2000	Zengerle et al.	
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	6	US 6,126,140	10-3-2000	Johnson et al.	
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	8	US 6,206,022 B1	03-27-2001	Tsai et al.	
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	15	US 6,626,416 B2	09-30-2003	Sharma et al.	
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FOREIGN PATENT DOCUMENTS								
Examiner	Cite	Foreign Patent Document			Name of Patentee or	Pages, Columns, Lines,		
Initials*	No.1	Country Code ³	Number ⁴	Kind Code ⁸ (if known)	Publication Date MM-DD-YYYY	Applicant of Cited Document	Where Relevant Passages or Relevant Figures Appear	T ⁶
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Kind Codes of U.S. Patent Documents at www.uspto.gov or MPEP 901.04.

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For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

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Applicant is to place a check mark here if English language Translation is attached.

Substitute for form 1449B/PTO Complete if Known Application Number 10/757,973 **INFORMATION DISCLOSURE** Filing Date January 13, 2004 STATEMENT BY APPLICANT First Named Inventor Xie, Jun Art Unit Unassigned (use as many sheets as necessary) Examiner Name Unassigned Sheet Attorney Docket Number 020859-002510US

	NON PATENT LITERATURE DOCUMENTS					
Examiner Initials *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T 2			
17	16	DEGANI et al., On the Effect of Residual Charges on the Pull-in Parameters of Electrostatic Actuators, Sensors and Actuators A 97-98 (2002), pp 563-568.				
	17	DUBOIS et al., Electrostatically Actuated Gas Microvalve Based on A Ta-SI-N Membrane, Institute of Microtechnology, University of Nuchatel, Switzerland, 2001, pp 535-538.				
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	26	WIJNGAART et al., A High-Storke, High-Pressure Electrostatic Actuator for Valve Applications, Sensors and Actuators, A 100 (2002), pp 264-271.				
	27	YAO et al., Dielectric Charging Effects on Parylene Electrostatic Actuators, IEEE, 2002, pp 614-617.				

Examiner	Date	
Signature	Considered	

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